

Correction

Correction: Gawlińska-Nęcek et al. Influence of Conditioning Temperature on Defects in the Double Al₂O₃/ZnO Layer Deposited by the ALD Method. *Materials* 2021, 14, 1038

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In the original publication [1], there were mistakes in Figures 5 and 6, as well as in the legend for Figure 5. The corrected Figures 5 and 6, together with the corrected legend for Figure 5, are presented below. The authors state that the scientific conclusions are unaffected. This correction was approved by the Academic Editor. The original publication has also been updated.

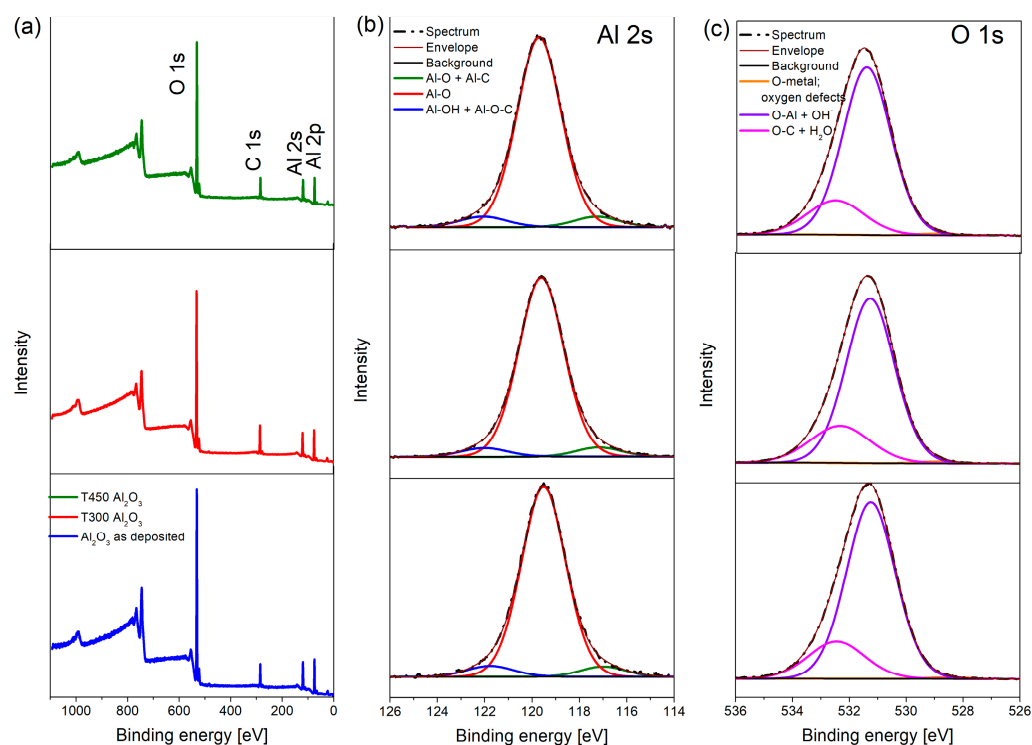


Figure 5. Al₂O₃ XPS: (a) survey spectra; (b) Al 2s spectra; (c) O 1s spectra, collected as deposited (bottom), after heating at 300 °C (middle), and after heating at 450 °C (top).



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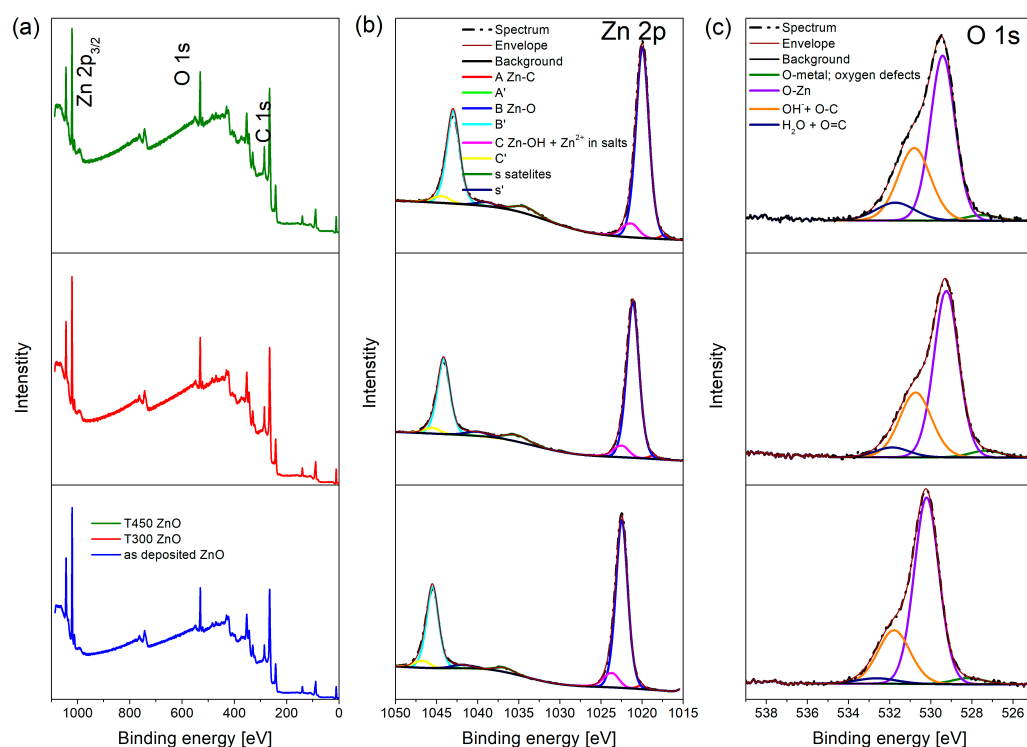


Figure 6. ZnO XPS: (a) survey spectra; (b) Zn 2p spectra; (c) O 1s spectra, collected as deposited (**bottom**), after heating at 300 °C (**middle**), and after heating at 450 °C (**top**).

Reference

1. Gawlińska-Nęcek, K.; Wlazło, M.; Socha, R.; Stefaniuk, I.; Major, Ł.; Panek, P. Influence of Conditioning Temperature on Defects in the Double Al₂O₃/ZnO Layer Deposited by the ALD Method. *Materials* **2021**, *14*, 1038. [[CrossRef](#)] [[PubMed](#)]

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